



PATENT APPLICATION
Docket No.: 4591-357
Client Ref. No. IC12241-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hong-Soo KIM, et al.

Serial No.: 10/726,788 Examiner: Wilson, Christian D.

Filed: December 2, 2003 Group Art Unit: 2891

Confirmation No.: 6111

For: METHODS OF FORMING SEMICONDUCTOR DEVICES
HAVING FIELD OXIDES IN TRENCHES AND DEVICES
FORMED THEREBY

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Commissioner for Patents
P.O. Box 1450
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AMENDMENT AFTER ALLOWANCE UNDER 37 CFR § 312

Responsive to the Notice of Allowance, dated July 28, 2005, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

ok to enter
CDW 11/1/05